

APPLICATION DATA SHEET

Electronic Version 0.0.11

Stylesheet Version: 1.0

Attorney Docket Number: ATMI-466

Publication Filing Type: new-utility

Application Type: utility

Title of Invention: COMPOSITION AND CHEMICAL VAPOR DEPOSITION METHOD FOR FORMING ORGANIC LOW K DIELECTRIC FILMS

Customer Number Correspondence Address: 25559



INVENTOR(s):

Primary Citizenship: US
Given Name: Neil
Middle Name: H
Family Name: Hendricks
Residence City: Sonora
Residence State: CA
Residence Country: US
Address: 16525 Habitat Tr.
Sonora CA, 95370 US